

<b>INFORMATION DISCLOSURE CITATION</b>  (Use several sheets if necessary)	Attorney Docket No.: 46884-5520	Serial No.: 10/594,949
	Applicants Takeshi SAKAMOTO et al.	Page 1 of 1
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## U.S. PATENT DOCUMENTS

## FOREIGN PATENT DOCUMENTS

## OTHER DOCUMENTS

(Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.)

	K. HAYASHI; "Inner Glass Marking by Harmonics of Solid-State Laser", Proceedings of 45 <sup>th</sup> Laser Materials Processing Conference, Dec. 1998, pgs. 23-28.
	K. MIURA et al., "Formation of Photo-Induced Structures in Glasses with Femtosecond Laser", Proceedings of 42 <sup>nd</sup> Laser Materials Processing Conference, Nov. 1997, pgs. 105-111.
	T. SANO et al., "Evaluation of Processing Characteristics of Silicon with Picosecond Pulse Laser", Preprints of the National Meeting of Japan Welding Society, No. 66, April 2000, pgs 72-73 (with at least partial English translation).

Examiner \_\_\_\_\_ Date Considered \_\_\_\_\_